

PATENT NUMBER and  
ISSUE DATE

U.S. UTILITY Patent Application

APPL NUM 10052878	FILING DATE 11/02/2001	CLASS 438	SUBCLASS 600+	GAU 28124	EXAMINER PERALTA
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\*\*APPLICANTS: Harshbarger William; Takehara Takako; Olsen Jeff; Qiu Regina; LeGrice Yvonne; Feng Guofu; Robertson Robert; Law Kam;

\*\*CONTINUING DATA VERIFIED:

THIS APPLICATION IS A CIP OF 08/500,728 07/11/1995 PAT 5,902,650 WHICH IS A CON OF 09/249,041 02/12/1999 PAT 6,352,910

\*\* FOREIGN APPLICATIONS VERIFIED:

PG-PUB	DO NOT PUBLISH <input type="checkbox"/>	RESCIND <input type="checkbox"/>	
Foreign priority claimed 35 USC 119 conditions met		<input type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> yes <input type="checkbox"/> no	ATTORNEY DOCKET NO
Verified and Acknowledged Examiner's initials			AMAT/827 - C 01
TITLE : Method of depositing amorphous silicon based films having controlled conductivity			
U.S. DEPT. OF COMM./PAT. & TM-PTO-436L(Rev. 12-94)			

NOTICE OF ALLOWANCE MAILED		CLAIMS ALLOWED	
		Total Claims 100	Print Claim for O.G.
Assistant Examiner		DRAWING	
		Sheets Draw.	Fig.s Draw.
ISSUE FEE		Print Fig.	
Amount Due	Date Paid		
<input type="checkbox"/> TERMINAL			
DISCLAIMER		Primary Examiner	
		Application Examiner	
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